

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) MAIL STOP AMENDMENT
Susumu KITAGAWA et al.) Group Art Unit: 1796
Application No.: 10/593,098) Examiner: Robert C. BOYLE
Filed: October 24, 2006) Confirmation No.: 7829
For: ORGANOMETALLIC COMP STRUCTURE, PRODUCTION METHOD THEREOF; AND FUNCTIONAL FILM, FUNCT COMPOSITE MATERIAL, FUNCTIONAL STRUCTURE ADSORPTION AND DESOR SENSOR USING THE ORGANOMETALLIC COMP STRUCTURE	TIONAL) AND) PTION)

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 16, 2009, please amend the above-identified application as follows.